



Docket No. 8733.307.00

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6/6/03

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re application of

Oh-Nam KWON

Group Art Unit: 2823

Application No.: 09/709,483

Examiner: T. Pham

Filed: November 13, 2000

For: METHOD OF MANUFACTURING A THIN FILM TRANSISTOR

REQUEST FOR EXAMINER APPROVAL OF DRAWING CHANGES

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants submit proposed drawing corrections as shown in red on the attached sheet comprising Figure 1. Specifically, element numbers 2 and 4 have been deleted, and the top occurrence of element number 1 has been changed to 3.

No new matter has been added. Favorable consideration is sought therefore.

Applicants hereby authorize the Commissioner of Patents to charges any fees necessary to complete this filing, including any fees required under 37 C.F.R. §1.136 for any necessary Extension of Time to make the filing of the attached documents timely, or credit any overpayment in fees, to Deposit Account No. 50-0911. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. §1.136 for the necessary extension of time. A copy of this sheet is enclosed.

Dated: May 27, 2003

Respectfully submitted,

Walter T. Bely

By Reg. No. 33,829

..... Song K. Jung

..... Registration No.: 35,210

MCKENNA LONG & ALDRIDGE LLP
1900 K Street, N.W.
Washington, DC 20006
Telephone: (202) 496-7500
Facsimile: (202) 496-7756
Attorneys for Applicant